

DECLARATION OF SOLE INVENTOR FOR PATENT APPLICATION

As the below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled: Methods Of Forming Void Regions, Dielectric Regions And Capacitor Constructions, the specification of which is attached hereto.

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims.

I acknowledge the duty to disclose information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations §1.56.

PRIOR FOREIGN APPLICATIONS:

I hereby state that no applications for foreign patents or inventor's certificates have been filed prior to the date of execution of this declaration.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under

1
2
3
4
5
6
7
8
9
10
11
12
13
14
15
16
17
18
19
20
21
22
23

Section 1001 of Title 18 of the United States Code and that such willful
false statement may jeopardize the validity of the application or any
patent issued therefrom.

* * * * *

Full name of sole inventor: Jerome Michael Eldridge

Inventor's Signature: Jerome Michael Eldridge

Date: Aug. 28, 1998

Residence: Los Gatos, California

Citizenship: U.S.

Post Office Address: 16605 Englewood Ave., Los Gatos, CA 95032